



**ELECTRONIC COPY**

LG811683526  
Report verification at igi.org



June 23, 2026  
IGI Report Number **LG811683526**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **16.58 X 11.15 X 7.72 MM**  
**GRADING RESULTS**  
Carat Weight **12.58 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

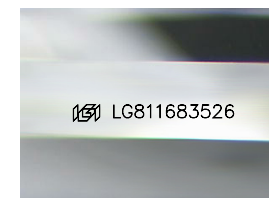
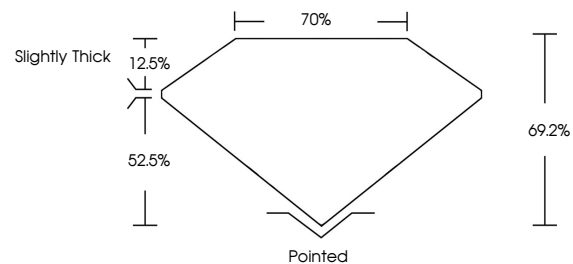
Carat Weight **12.58 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG811683526**

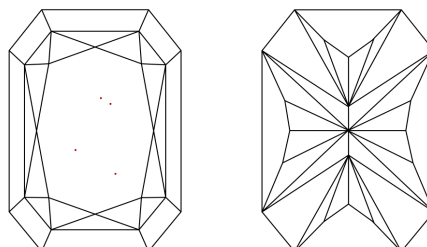
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

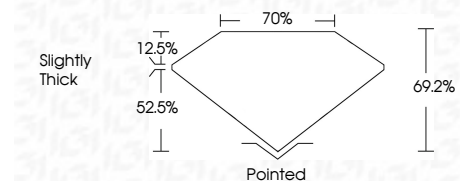
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
16.58 X 11.15 X 7.72 MM  
12.58 CARATS  
F  
VVS 2  
69.2%  
70%  
Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG811683526  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa